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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/684,079	10/09/2003	Christopher Bencher	AMAT/2966.CI/DSM/BCVD/JW 3052		
44257 75	90 08/10/2005		EXAMINER		
MOSER, PAT	TERSON & SHERIDA	YEVSIKOV, VICTOR V			
APPLIED MATERIALS, INC. 3040 POST OAK BOULEVARD, SUITE 1500 HOUSTON, TX 77056			ART UNIT	PAPER NUMBER	
			2891		

DATE MAILED: 08/10/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

SUPPLEMENTAL Notice of Allowability

Application No.	Applicant(s)		
10/684,079	BENCHER ET AL.		
Examiner	Art Unit		
Victor V. Vevsikov	3801		



	Victor V. Yevsikov	2891	
The MAILING DATE of this communication appears All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF the Office or upon petition by the applicant. See 37 CFR 1:313	(OR REMAINS) CLOSED in the or other appropriate community of the IGHTS. This application is sub-	nis application. If not includ	ed THIS
1. This communication is responsive to PAPER, FILED 10/09,	<u>/2003</u> .		
2. The allowed claim(s) is/are 1-29.		· .	
3. The drawings filed on <u>09 October 2003</u> are accepted by the	e Examiner,	٠	
 4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have Copies of the certified copies of the priority documents have Copies of the certified copies of the priority documents have Certified copies of the certified copies of the priority documents have * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 	been received. been received in Application I cuments have been received in the communication to file a	Non this national stage applica	÷
5. A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give	tted. Note the attached EXAMI s reason(s) why the oath or de	NER'S AMENDMENT or Neclaration is deficient.	OTICE OF
 6. ☐ CORRECTED DRAWINGS (as "replacement sheets") mus (a) ☐ including changes required by the Notice of Draftspers 1) ☐ hereto of 2) ☐ to Paper No./Mail Date (b) ☐ including changes required by the attached Examiner's Paper No./Mail Date 	on's Patent Drawing Review (·	
Identifying Indicia such as the application number (see 37 CFR 1, each sheet. Replacement sheet(s) should be labeled as such in the	84(c)) should be written on the d	rawings in the front (not the	back) of
DEPOSIT OF and/or INFORMATION about the depose attached Examiner's comment regarding REQUIREMENT F	it of BIOLOGICAL MATER	AL must be submitted. N	lote the
Attachment(s) 1. Notice of References Cited (PTO-892) 2. Notice of Draftperson's Patent Drawing Review (PTO-948)	<u> </u>	nal Patent Application (PTC)-152)
3.] Information Disclosure Statements (PTO-1449 or PTO/SB/08	6. ☐ Interview Sumr Paper No./Mai	il Date	
Paper No./Mail Date <u>01/26/0</u> 4			
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's Sta 9. □ Other	tement of Reasons for Allo	wance

9. Other _____.

Application/Control Number: 10/684,079

Art Unit: 2891

DETAILED ACTION

Allowable Subject Matter

Claims 1-29 are allowed.

The following is an examiner's statement of reasons for allowance:

Prior art does not teach a method of processing a substrate, wherein depositing a silicon carbide barrier layer, a silicon carbide material (anti-reflective coating) and a silicon carbide etch stop and wherein the silicon carbide material has a dielectric constant of less than about 5 and has a reflectivity of about 7 percent or less at ultraviolet wavelengths, and depositing a photoresist layer adjacent the etch stop.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Victor Yevsikov whose telephone number is (571) 272-1910. The examiner can normally be reached on Monday –Thursdays 8:00-5:30.

If attempts to reach the examiner by telephone are unsuccessful, examiner's supervisor, William B. Baumeister, can be reached on (571) 272-1722. The fax phone numbers for the organization where this application or processing is assigned is (703) 873-9306.

Art Unit: 2891

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published application may be obtained from either Private PAIR or Public PAIR. Status information for unpublished application is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

May 2, 2005

Victor Yevsikov Examiner

B. WILLIAM BAUMEISTER SUPERVISORY PATENT EXAMINER